Synthesis and Thermal Decomposition Mechanism Study of a Novel Iridium Precursor

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Abstract. Ir(TFA)₃ (TFA=1,1,1-trifluoro-2,4-pentanedionate) metal complexes with high purity was successfully synthesized. The metal complexes have been characterized by elemental analysis, infrared spectroscopy, nuclear magnetic resonance spectroscopy. The volatility of metal complexes was studied by thermogravimetry analysis. And a possible decomposition mechanism was studied by mass spectroscopic analysis method. The novel iridium complexes can be severed as precursor in metalorganic chemical vapor deposition of iridium films. iridium films were deposited by metalorganic chemical vapor deposition method, and the Ir(TFA)₃ complex was used as precursor. The iridium thin films were characterized by X-ray diffraction and scanning electron microscopy in order to determine crystallinity and surface morphology.

1 Introduction

Noble metal thin films have been extensively studied by both the traditional and microelectronics industries for potential applications such as anti-corrosion and anti-oxidation coating [1-2], or in the manufacture of bottom electrodes for high-density memory devices and ferroelectric capacitors [3-5]. Iridium is considered to be one of the best of these transition metal elements, as it possesses a high work function, a stable conductive oxide phase, IrO₂, and excellent electrical properties [6]. Although physical sputtering [7] seems to be a good choice of method for depositing such iridium metal-containing thin films, metalorganic chemical vapor deposition (MOCVD) will eventually become the preferred method because of its several major advantages, i.e., good conformal coverage, selective deposition on the substrate surface, the capacity for scale-up production with high throughput, and the ability to produce metal-stable materials at low temperature [8].

Various iridium precursors have been studied [9-18] in recent years. Hoke [9] and Sun [10] has used cyclooctadiene complexes of iridium co-dosed with O₂ for MOCVD iridium films growth and obtained pure iridium films at temperature between 122oC and 35 °C. Goto [11],Vargas [12],Gelfond[13] and Sun[14] have used tris-acetylacetonate iridium as precursor and obtained pure iridium films at temperature between 180 °C and 350 °C. Tris-(allyl)-iridium, an air sensitive precursor, was used to produce clean deposits at temperature 100 °C, under H₂, on SiO₂ substrates[15].Among these precursors, Tris-acetylacetonate iridium (Ir(AA)₃) complex was the best choice due to its excellent air stability. However its high melting point and low volatility limited its possible use field. It was suggested [16] that the volatility of metal β-diketonates complex would be improved if the fluorine substitution were introduced onto the β-diketonates ligand. In this paper, iridium fluorinated β-diketonates complex was successfully synthesized from IrCl₃ and HTFA in CCl₄. The structure of Ir(TFA)₃ was characterized by elemental analysis, infrared spectroscopy (IR), nuclear magnetic resonance (1H-NMR) spectroscopy. The volatility of metal complex was studied by thermogravimetry (TG) analysis. And a possible decomposition mechanism was studied by mass spectroscopic analysis method.

Iridium thin films were prepared by MOCVD on glass substrates, and iridium fluorinated β-diketonates complex was used as precursor. The structure and morphology of the iridium thin films were characterized by X-ray diffraction (XRD) and scanning electron microscopy(SEM).

2 Experimental

2.1 Preparation of Ir(TFA)₃ complex

Ir(TFA)₃ was obtained by the following procedure. Firstly, the IrCl₃ solution was prepared by the reduction of H₂IrCl₆.nH₂O. Secondly, the ligand trifluorooracetylacetone was synthesized by claisen condensation method. Thirdly, the ligand dissolved in a 2M NH₃.H₂O aqueous solution was dropped continuously to the IrCl₃ in ethanol solution, followed by the addition
of 2M NH₃·H₂O aqueous solution to adjust the pH value of the mixture to 8.5. At last, the reaction mixtures have been refluxed for 8h. The resulting product was collected by filtration and dried under vacuum. The product was purified by recrystallization (system a benzene-hexane).

2.2 Characterization of Ir(TFA)₃ complex

The purity of the sample was characterized by carbon and hydrogen elemental analysis in a Perkin-Elmer 2400 CHN instrument. Nuclear magnetic resonance (1H-NMR) spectrum was obtained using an INOVA 400 spectrometer for sample dissolved in CDCl₃. The Fourier transform infrared (FTIR) spectrum was recorded from 400 to 4000 cm⁻¹ using the FTIR spectrometer, model WQF-310. The sample was mixed with KBr powder, pressed into a self-supporting disk, and then placed at the center of the IR cell for experiment. The thermogravimetry (TG) analysis was measured in a N₂ flow of 60ml/min at a heating rate of 10 °C /min in ambient pressure from 25 °C to 400 °C using TG/Q50. In order to obtain more explicit and idiographic about decomposition mechanism of the metal complex, a mass spectrometer (model HP 5989B) was used to obtain the cracking patterns of Ir(TFA)₃. The sample was ionized by the electron impact (EI) method and the scanned mass range was from 1 to 800m/z.

2.3 Iridium thin films prepared by MOCVD

The MOCVD experiments were performed in a vertical hot-wall reactor. The deposition temperature used was at 350–500 °C. The iridium films were deposited on glass substrates. The phase composition and structure of the iridium thin films were characterized by X-ray diffraction (XRD) (RigakuD/Max-2400) with CuKα radiation. The surface morphologies of the thin films were examined using a scanning electron microscope (Hitachi-S4800).

3 Results and discussion

3.1 Characterization of Ir(TFA)₃ complex

The IR spectroscopy of Ir(TFA)₃ and HTFA were showed in (Fig. 1). The peak 1612 cm⁻¹, 1525 cm⁻¹represent the vibration modes and stretching modes of the C-O and C-C bonds in the complex ring structure. Compare to the free ligand, the vibration modes and stretching modes of the C-O and C-C bonds present to 1715 cm⁻¹, 1640 cm⁻¹. The peaks brought visible red shift respectively. The results showed that the ligand have chelated with iridium. The other peaks can be divided into four parts : (1)The peaks between 1300 and 1400 cm⁻¹ and those between 900 and 1100 cm⁻¹are due to the CH₃ and CF₃ groups; (2) peaks between 1100 and 1300 cm⁻¹ and those between 700 and 900 cm⁻¹ can be assigned to various vibrational modes of the C–CF₃ bond; (3) peaks around 800 cm⁻¹ represent the out-of-plane bending modes of the C–H bond between the two carbonyl groups; and (4) peaks at 451 and 669 cm⁻¹ are due to the stretching mode of the Ir–O bond.

Figure 1. IR spectroscopy of Ir(TFA)₃ and HTFA

The purity of the complex was checked by carbon and hydrogen elemental analysis. Anal. Calcd. for IrC₁₅H₁₂O₆F₉(Ir(TFA)₃): C 27.66, H 1.857. Found: C 27.65, H 1.853. The results showed the Ir(TFA)₃ was synthesized successfully with high purity. The NMR spectroscopy has been applied for a more detailed investigation of the organometallic structure of the complex to complement the elemental analyses and IR data forwards. In the ¹H-NMR spectrum of Ir(TFA)₃, there are two peaks at 2.123 and 5.897 ppm, which can be assigned, respectively, to the methyl groups protons(R₁:CH₃) and the proton boned to the carbon between the two carbonyl groups(R₂:CH) in TFA. The relative area ratio of the two peaks is close to the ratio of proton quantities in the two groups correspondingly, which is R₁/R₂=3. The results concluded from ¹H-NMR spectrum confirm that the prepared Ir(TFA)₃ is of high purity, in agreement with elemental analysis.

Figure 2. ¹H-NMR spectrum of Ir(TFA)₃

3.2 TG analysis
Fig. 3 is the TG curves of the samples in N2 which shows the sublimation features of Ir(TFA)$_3$ and Ir(AA)$_3$. The Ir(TFA)$_3$ maintains its initial weight up to about 180 °C in N$_2$ corresponding its sublimation temperature, then starts to lose weight significantly above 230 °C, and no further weight loss appears up to 290 °C. The residue amount is about 2.53% of the initial weight. The Ir(AA)$_3$ maintains its initial weight up to about 220 °C in N$_2$ corresponding its sublimation temperature, then starts to lose weight significantly above 260 °C, and no further weight loss appears up to 300 °C. The residue amount is about 2.76% of the initial weight. The TG results show that the Ir(TFA)$_3$ is high volatile than Ir(AA)$_3$, which may be served as precursor in MOCVD of iridium films.

![Figure 3. Thermogravimetry curves of Ir(TFA)$_3$ and Ir(AA)$_3$.](image)

### 3.3 Mass spectroscopic analysis

Mass spectrometry was carried out to provide more insight into the mechanism of decomposition and helpful information to MOCVD deposition [17]. Fig. 4 shows a typical mass spectrum for Ir(TFA)$_3$ at 160oC, major peaks of highest mass are observed at m/z=652, 650, 499, 497, 85, 69, 85 corresponding to [193Ir(TFA)$_3$]+, [191Ir(TFA)$_3$]+, [193Ir(TFA)$_2$]+, [191Ir(TFA)$_2$]+, [OCCH3COCH2]+, +CF3, +OCCH3, respectively.

![Figure 4. Mass spectrum of Ir(TFA)$_3$ taken at 160°C.](image)

The mass fragments reveal a possible decomposition process, which was described in Fig. 5: (a) at the beginning the CF3 group detached from TFA ligand, and then the OCCHCOCH$_3$ group in the same TFA group; (b) the obtained [193Ir(TFA)$_2$]+ will continue to decompose similar to (a). The CF3 group will be lost from TFA ligand, and then the OCCHCOCH$_3$ group in the same TFA group; (c) the obtained [193Ir(TFA)$_3$]+ will lose the Ir3+, then the [CH3COCH2OCOF3]+ will decompose according to two different processes. At last, the +CF3, [COCH2COCH3]+, [COCH3]+ ion were obtained in the system.

![Figure 5. Possible decomposition mechanism of Ir(TFA)$_3$.](image)

### 3.4 Characterization of Iridium thin films

Iridium thin films were prepared by MOCVD on glass substrates. The structure and morphology of the iridium thin films were characterized by X-ray diffraction (XRD) and SEM. Fig. 6 displays the XRD patterns of the Ir films on glass substrates at the growth temperature of 400°C. The 20 scan data of the films exhibited strong 20 peaks at 40.8°, 47.4° and 69.3°, 83.6°, 88.1° respectively, corresponding to the (111), (200), (220), (311) and (222) peaks of Ir, revealing that the Ir films were fully polycrystalline and no evidence for a preferential orientation was found.

![Figure 6. XRD patterns of the Ir films on glass substrates.](image)
Figure 6. The XRD pattern of iridium film deposited on glass substrate.

Fig. 7 shows the surface morphology images of iridium thin films. Thus resultant iridium films were dense, smooth and homogeneous, with an average grain size of 10–40 nm. We speculate that growth starts probably with the isolated iridium clusters, which grow three dimensionally. Thus the growth mechanism follows the Volmer–Weber model. More detailed investigations will be presented elsewhere.

Figure 7. The SEM image of iridium thin film.

The energy dispersive spectrometer (EDS) data of the iridium films is shown in Fig. 8. The spectra reveal the presence of the Si, Au, Ca, Cu, Ir elements in the films. Among these elements, Si, Ca, and Cu are from the glass substrates and the equipment itself, and Au was deposited by sputtering in order to improve the films conductivity. Thus, the presence of Ir in the films is further confirmed by the EDS data whereby the Ir peak is detected in the EDS spectra.

Figure 8. The EDS analysis of the iridium film deposits at 400°C on glass substrates.

4 Conclusions

Ir(TFA)3 complex powder with high purity was successfully synthesized from IrCl3 and HTFA in ethanol/aqueous solution followed by recrystallization from benzene-hexane system. The TG analysis shows that the complex sublimates from 180°C to 29°C, and the residue amount is about 2.53% of the initial weight. The TG results show that the Ir(TFA)3 is high volatile than Ir(AA)3, which may be served as precursor in MOCVD of iridium films. The possible decomposition mechanism was obtained by mass spectroscopic analysis method. Ir(TFA)3 complex powder was used as precursor, then the iridium thin films were successfully synthesized on glass substrates at 400°C by the MOCVD method. Deposited films were found to consist of islands grown on the glass substrate. The growth mechanism follows the Volmer–Weber model.

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